Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known		
				Application Number	10/687,288	
				Filing Date	October 15, 2003	
				First Named Inventor	Wang Yueh 1795	
				Art Unit		
				Examiner Name	Daborah Chacko Davis	
Sheet	1	of	1	Attorney Docket Number		

NON PATENT LITERATURE DOCUMENTS							
Examiner Initials*	Cite No.¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>				
		"Introduction to Electron Beam Lithography," http://dot.che.gatech. edu/henderson/introduction_to_electron_beam_lithography.htm, printed from internet on					
		8/27/03, 13 pages					
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Examiner	/Daborah Chacko-Davis/	Date	12/03/2010	
Signature	,	Considered		

Based on PTO/SB/08B (08-03) as modified by Blakely, Solokoff, Taylor & Zafman (wlr) 08/11/2003. Send To: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

<sup>\*</sup>Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

<sup>&</sup>lt;sup>1</sup>Applicant's unique citation designation number. <sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.